

INTERNATIONAL GEMOLOGICAL INSTITUTE

# **ELECTRONIC COPY**

# LABORATORY GROWN DIAMOND REPORT

June 15, 2022	
IGI Report Number	LG478127204
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	EMERALD CUT
Measurements	6.89 X 5.09 X 3.34 MM
GRADING RESULTS	
Carat Weight	1.08 CARAT
Color Grade	н

### ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	VERY GOOD
Fluorescence	NONE
Inscription(s)	GROWN IN THE USA Pat.6,858,078 IGI LG478127204

**VS 1** 

### Comments:

Clarity Grade

As Grown - No indication of post-growth treatment. This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) process.



# LABORATORY GROWN DIAMOND REPORT LG478127204 Report verification at igi.org

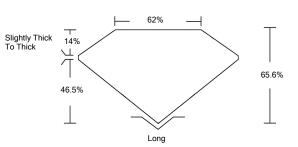
# PROPORTIONS

**CLARITY CHARACTERISTICS** 

**KEY TO SYMBOLS** 

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.



# LABORATORY GROWN DIAMOND REPORT

### GRADING SCALES

### CLARITY

IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	۱ <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

# COLOR

D	Е	F	G	Н	Т	J	Faint	Very Light	Light
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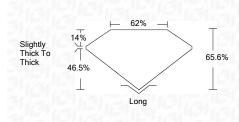
LASERSCRIBE<sup>SM</sup> Sample Image Used



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